

## Special Issue

# Women's Special Issue Series: Metrology

### Message from the Guest Editors

Although a range of policy actions have been made to promote gender equality, female representation in STEM areas is still unsatisfactory. The number of male researchers working in STEM is much larger than for women, and this is a constant in countries all over the world. This problem is also evident, of course, in metrology. The imbalance between the number of male and female researchers affects the visibility of the work done by women, who rarely have positions that allow them to appear as individual authors or first authors of scientific articles. This Special Issue aims to give visibility and better dissemination to research works in metrology where the lead author is a woman (i.e., a person who identifies as a woman) or that are completely authored by women. Although we encourage women scientists leading research on metrology to submit an original manuscript to this Special Issue, we want to promote a policy of gender equality; we welcome submissions from all authors, irrespective of the gender identity.

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### Guest Editors

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### Deadline for manuscript submissions

closed (20 January 2024)



## Metrology

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### Message from the Editor-in-Chief

*Metrology* draws together researchers from diverse areas of metrology or measurement technology in a wide variety of applications. I encourage you to submit your manuscripts for consideration or publication in the area of measurement engineering, according to the scope of the journal. *Metrology* is supported by our authors and their institutes through low article processing charges (APC) for accepted papers. We hope you will support the journal by becoming one of our authors.

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